INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 19, 2024	
IGI Report Number	LG639439800
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	7.78 X 5.53 X 3.70 MM

GRADING RESULTS

Carat Weight	1.58 CARAT
Color Grade	E
Clarity Grade	VVS 2

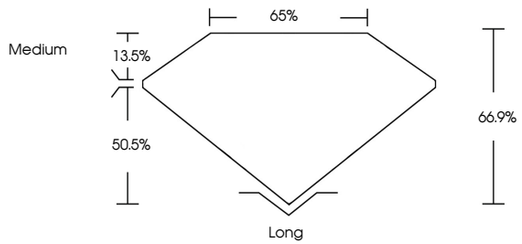
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG639439800

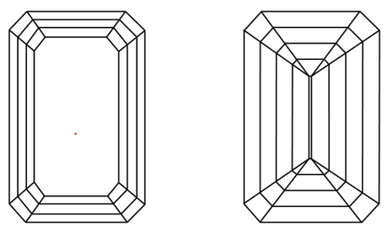
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG639439800
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

IF	VVS 1-2	VS 1-2	SI 1-2	I 1-3
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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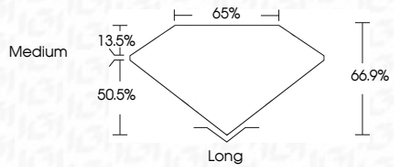

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IGI

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IGI Report No LG639439800
EMERALD CUT
7.78 X 5.53 X 3.70 MM

Carat Weight	1.58 CARAT
Color Grade	E
Clarity Grade	VVS 2
Depth	66.9%
Table	65%
Girdle	Medium
Culet	Long
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG639439800

Comments:
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Type IIa